



## UNITED STATES PATENT AND TRADEMARK OFFICE

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Sib Data Sheet

CONFIRMATION NO. 1681

SERIAL NUMBER 09/910,110	FILING DATE 07/20/2001 RULE	CLASS 029	GROUP ART UNIT 3729	ATTORNEY DOCKET NO. 1864 P 071
<b>APPLICANTS</b> Peter V. Loeppert, Hoffman Estates, IL; Sung Bok Lee, Chicago, IL;				
<b>** CONTINUING DATA *****</b> <i>No</i>				
<b>** FOREIGN APPLICATIONS *****</b> <i>No</i>				
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> ** 09/06/2001				
Foreign Priority claims: 35 USC 119 (a-d) conditions met'	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY IL	SHEETS DRAWING 3	TOTAL CLAIMS 20
Verified and Acknowledged _____ Examiner's Signature	Initials	INDEPENDENT CLAIMS 3		
<b>ADDRESS</b> Thomas K. Stine Wallenstein & Wagner, Ltd. 53rd Floor 311 South Wacker Drive Chicago, IL 60606-6630				
<b>TITLE</b> Raised microstructure of silicon based device				
FILING FEE RECEIVED 710	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other <input type="checkbox"/> Credit		